

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Stefan F. Brouwer

Application No.: 10/549,963

Confirmation No.: 8316

Filed: August 3, 2006

Art Unit: 3632

Docket No. 65529-0006

Examiner: Ramon O. Ramirez

For: MIRROR SUPPORTING PLATE, MIRROR  
ADJUSTING MECHANISM, METHOD FOR  
MANUFACTURING A MIRROR SUPPORTING  
PLATE, AND METHOD FOR ASSEMBLING A  
MIRROR ADJUSTING MECHANISM

Commissioner for Patents  
Mail Stop AF  
Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT PURSUANT TO 37 C.F.R. § 1.116**

Dear Commissioner:

In response to the Office Action of March 14, 2008, please amend the above-identified application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

A Request for Continued Examination (RCE) and a Request for an Extension of Time (one month) accompanies this submission.

**CERTIFICATE OF TRANSMISSION**

I hereby certify that this correspondence is, on the date shown below, being transmitted to the U.S. Patent and Trademark Office via the Office's electronic filing system EFS-Web addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: July 7, 2008

/Donna Crumit/  
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